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Yong Ju PARK, Eun Kyu KIM and Kwang Moo KIM

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Name: KOREA INSTITUTE OF SCIENCE AND TECHNOLOGY

Address: 39-1 Hawolgok-dong
Seongbuk-gu, Seoul, KoreaAdditional name(s) of conveying party(ies) attached? ☒ Yes ☐ No

3. Nature of Conveyance:

- ☒ Assignment ☐ Merger
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☐ Other

Execution Date: August 30, 2001

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4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is:

A. Patent Application No.(s)

09/947,375

B. Patent No.(s)

Additional numbers attached? ☐ Yes ☒ No

5. Name and address of party to whom correspondence concerning document should be mailed:



22850

6. Total applications and patents involved: 1

7. Total fee (37 CFR 3.41): \$40.00

- ☒ Enclosed
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Nov. 2, 2001

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PATENT
REEL: 012296 FRAME: 0213

Assignment of Application

Page 1 of 2

INSERT NAMES
AND RESIDENCE
ADDRESSES OF
THE INVENTORS:

WHEREAS, I (WE) PARK, Yong Ju; KIM, Eun Kyu; and KIM, Kwang Moo, Assignors, Citizens of
Republic of Korea, Residing at SK Apt. 106-513, 105 Jongam-dong, Seongbuk-gu, Seoul 136-090, Korea;
Sang-A Apt. 2-110, 299 Chang-dong, Dobong-gu, Seoul 132-040, Korea; and Kyungnam Apt. 7-207,
Banpo 2-dong, Seocho-gu, Seoul 137-765, Korea,

_____, respectively,

have invented certain new and useful improvements in : METHOD FOR ALIGNING QUANTUM
DOTS AND SEMICONDUCTOR DEVICE FABRICATED BY USING THE SAME

INSERT TITLE
OF INVENTION:

for which an application for Letters Patent was executed on August 30, 2001

INSERT DATE IN-
VENTORS SIGNED
DECLARATION:

(Application No. 09/947,375 filed September 7, 2001), and

WHEREAS, KOREA INSTITUTE OF SCIENCE AND TECHNOLOGY

INSERT NAME
AND ADDRESS OF
COMPANY OR
OTHER
ASSIGNEE:

(hereinafter referred to as "ASSIGNEE") having a place of business at : 39-1 Hawolgok-dong,
Seongbuk-gu, Seoul, Korea

is desirous of acquiring the entire right, title and interest in and to said invention and in and to any Letters Patent that may be granted therefore in the United States and its territorial possessions and in any and all foreign countries;

NOW, THEREFORE, in consideration of the sum of FIVE DOLLARS(\$5.00), the receipt whereof is hereby acknowledged, and for other good and valuable consideration, I(WE), by these presents do sell, assign and transfer unto said ASSIGNEE, the full and exclusive right to the said invention in the United States and its territorial possessions and in all foreign countries and the entire right, title and interest in and to any and all Letters Patent which may be granted therefor in the United States and its territorial possessions and in any and all foreign countries and in and to any and all divisions, reissues continuations, substitutions and renewals thereof.

I (WE) hereby authorize and request the Patent Office Officials in the United States and its territorial possessions and any and all foreign countries to issue any and all of said Letters Patent, when granted, to said ASSIGNEE as the assignee of my (our) entire right, title and interest in and to the same, for the sole use and behalf of said ASSIGNEE, its (his) successors and assigns, to the full end of the term for which said Letters Patent may be granted, as fully and entirely as the same would have been held by me (us) had this Assignment and sale not been made.

Further, I (WE) agree that I (WE) will communicate to said ASSIGNEE or its (his) representatives any facts known to me(us) respecting said invention, and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuation, substitute, renewal and reissue applications, execute all necessary assignment papers to cause any and all of said Letter Patent to be issued to said ASSIGNEE, make all rightful oaths, and, generally do everything possible to aid said ASSIGNEE, its(his) successors and assigns, to obtain and enforce proper protection for said invention in the United States and its territorial possessions and in any and all foreign countries.

The undersigned hereby grant(s) the firm of Oblon, Spivak, McClelland, Maier & Neustadt, P.C. of Fourth Floor, 1755 Jefferson Davis Highway, Arlington, Virginia 22202 the power to insert on this assignment any further identification, including the application number and filing date, which may be necessary or desirable in order to comply with the rules of the United States Patent and Trademark Office for recordation of this document.

Date: Aug 30, 2001

(Signature of invention)

PARK, Yong Ju

Date: Aug. 30, 2001

(Signature of invention)

KIM, Eun Kyu

Date: Aug. 30, 2001

(Signature of invention)

KIM, Kwang Moo

Date: _____

(Signature of invention)

Date: _____

(Signature of invention)

Date: _____

(Signature of invention)

Date: _____

(Signature of invention)

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.
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